

Catalytic synergy of WS₂ anchored PdSe₂ for highly sensitive hydrogen gas sensor

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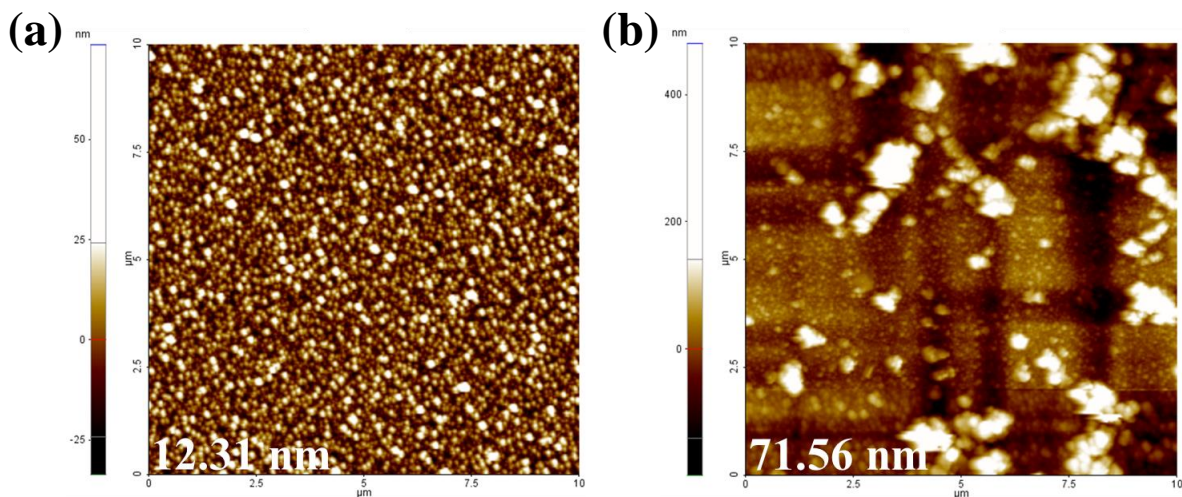


Fig. S1 AFM images (a) pristine PdSe₂ and (b) WS₂ decorated PdSe₂ thin film

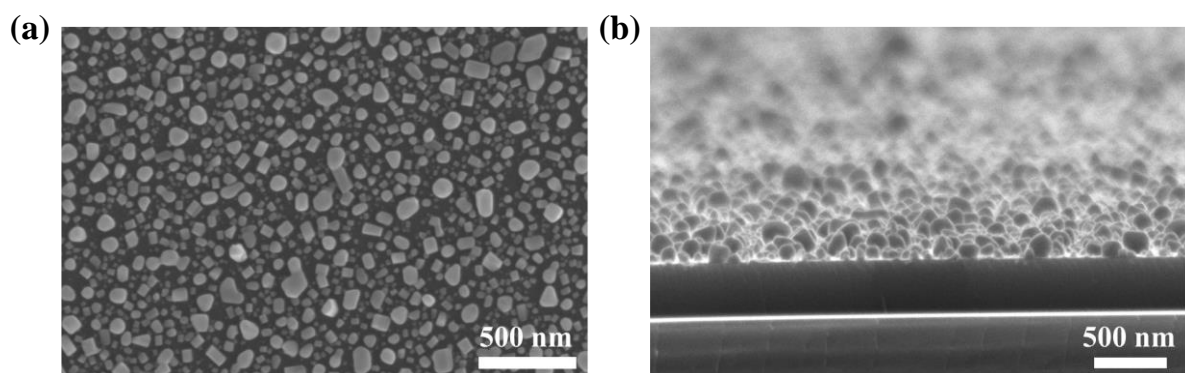


Fig. S2 FE-SEM images (a) pristine PdSe₂ and (b) cross-sectional image of pristine PdSe₂

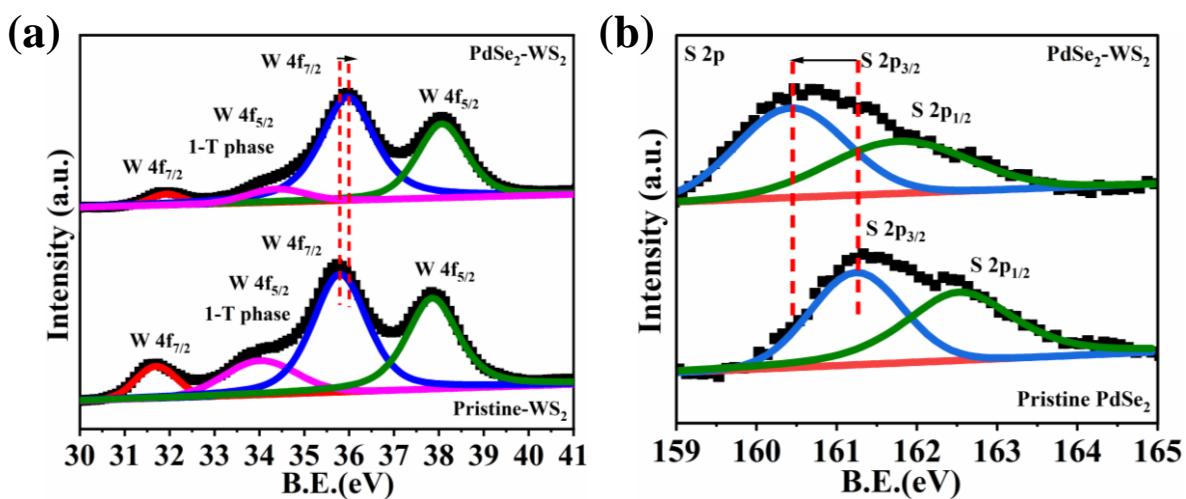


Fig. S3 XPS core level spectra of (a) W 4f_{7/2} and W 4f_{5/2} (d) S 2p_{3/2} and S 2p_{1/2} of pristine WS₂ and WS₂ anchored PdSe₂, respectively.

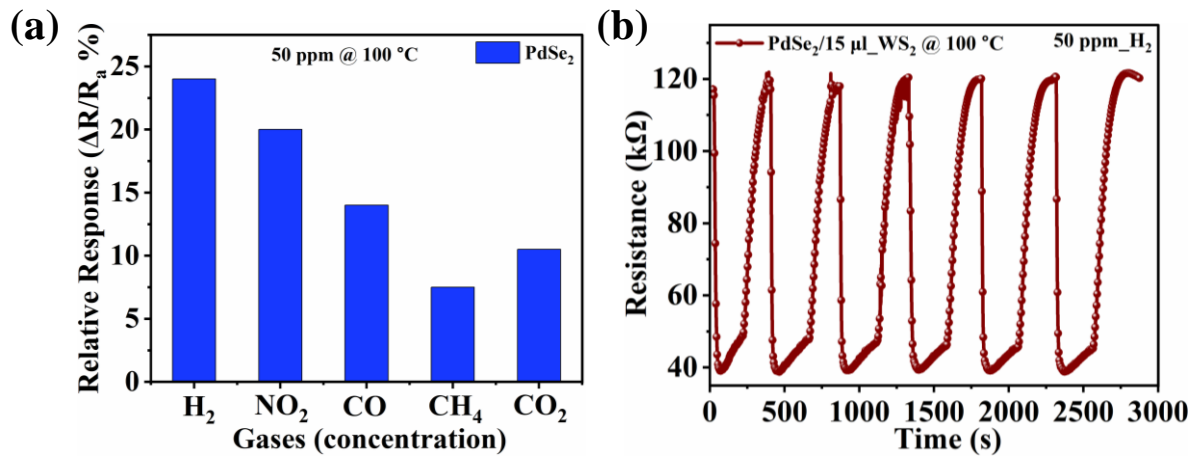


Fig. S4 (a) selectivity of pristine PdSe₂ towards various gases (b) repeatability of PdSe₂/WS₂ heterostructure.

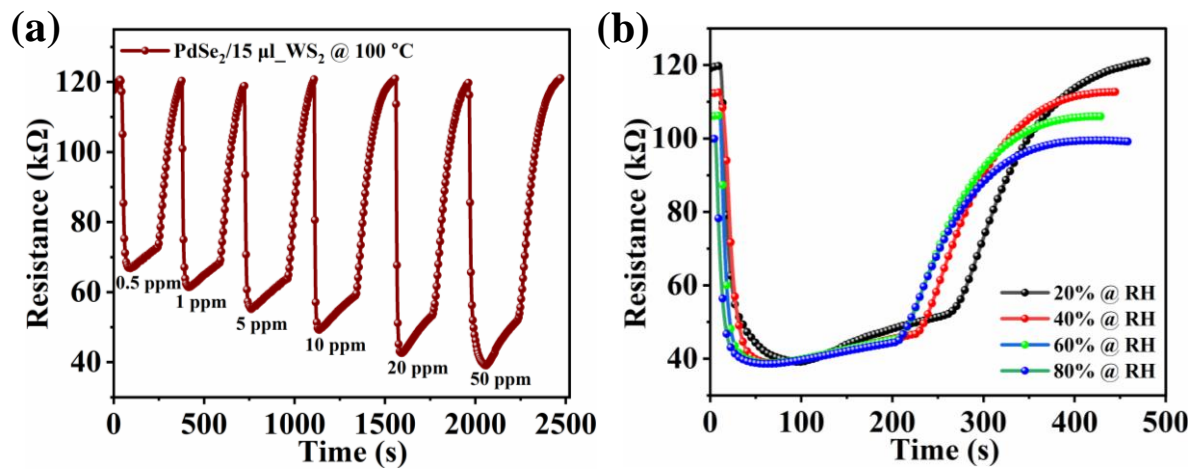


Fig. S5 (a) Resistance of the 15 μ l WS₂ anchored PdSe₂ sensor at 100 °C from 0.5 to 50 ppm H₂ gas. (b) Resistance of the PdSe₂/WS₂ heterostructure under different RH condition of 20%, 40%, 60% and 80% to 50 ppm H₂ at 100 °C.